



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hideki MATSUMURA, et al.**

Group Art Unit: **2818**

Serial No.: **10/041,609**

Examiner: **BERRY, Renee R.**

Filed: **January 10, 2002**

P.T.O. Confirmation No.: **5375**

For. **METHOD AND APPARATUS FOR DEPOSITING A THIN FILM, AND SEMICONDUCTOR DEVICE HAVING A SEMICONDUCTOR-INSULATOR JUNCTION**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: September 11, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 23, 2003 for two months from July 23, 2003 to September 23, 2003.

Attached please find a check in the amount of \$410.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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SK/fs  
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PATENT TRADEMARK OFFICE